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| Autore                  | Williams David B  |
| Titolo                  | Transmission Electron Microscopy : A Textbook for Materials Science /<br>/ by David B. Williams, C. Barry Carter  |
| Pubbl/distr/stampa      | New York, NY : , : Springer US : , : Imprint : Springer, , 1996   |
| ISBN                    | 1-4757-2519-1   |
| Edizione                | [1st ed. 1996.]   |
| Descrizione fisica      | 1 online resource (XXIX, 729 p. 1722 illus.)  |
| Disciplina              | 621.36<br>620.11299   |
| Soggetti                | Spectrum analysis<br>Surfaces (Physics)<br>Condensed matter<br>Materials - Analysis<br>Biophysics<br>Spectroscopy<br>Surface and Interface and Thin Film<br>Condensed Matter Physics<br>Characterization and Analytical Technique<br>Bioanalysis and Bioimaging   |
| Lingua di pubblicazione | Inglese   |
| Formato                 | Materiale a stampa  |
| Livello bibliografico   | Monografia  |
| Nota di bibliografia    | Includes bibliographical references at the end of each chapters and<br>index.   |
| Nota di contenuto       | 1 The Transmission Electron Microscope -- 2 Scattering and Diffraction<br>-- 3 Elastic Scattering -- 4 Inelastic Scattering and Beam Damage -- 5<br>Electron Sources -- 6 Lenses, Apertures, and Resolution -- 7 How to<br>"See" Electrons -- 8 Pumps and Holders -- 9 The Instrument -- 10<br>Specimen Preparation -- 11 Diffraction Patterns -- 12 Thinking in<br>Reciprocal Space -- 13 Diffracted Beams -- 14 Bloch Waves -- 15<br>Dispersion Surfaces -- 16 Diffraction from Crystals -- 17 Diffraction<br>from Small Volumes -- 18 Indexing Diffraction Patterns -- 19 Kikuchi<br>Diffraction -- 20 Obtaining CBED Patterns -- 21 Using Convergent-<br>Beam Techniques -- 22 Imaging in the TEM -- 23 Thickness and<br>Bending Effects -- 24 Planar Defects -- 25 Strain Fields -- 26 Weak-<br>Beam Dark-Field Microscopy -- 27 Phase-Contrast Images -- 28 High- |

Resolution TEM -- 29 Image Simulation -- 30 Quantifying and Processing HRTEM Images -- 31 Other Imaging Techniques -- 32 X-ray Spectrometry -- 33 The XEDS-TEM Interface -- 34 Qualitative X-ray Analysis -- 35 Quantitative X-ray Microanalysis -- 36 Spatial Resolution and Minimum Detectability -- 37 Electron Energy-Loss Spectrometers -- 38 The Energy-Loss Spectrum -- 39 Microanalysis with Ionization-Loss Electrons -- 40 Everything Else in the Spectrum -- Acknowledgements for Figures.

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## Sommario/riassunto

Electron microscopy has revolutionized our understanding of the extraordinary intellectual demands required of the materials by completing the processing-structure-property relationship in order to do the job properly: crystallography, links down to atomic levels. It now is even possible to determine diffraction, image contrast, inelastic scattering events, and to tailor the microstructure (and meso structure) of materials spectroscopy. Remember, these used to be fields in themselves to achieve specific sets of properties; the extraordinary abilities. Today, one has to understand the fundamentals of modern transmission electron microscopy-TEM- of all of these areas before one can hope to tackle significant instruments to provide almost all of the structural, phase, and other problems in materials science. TEM is a technique of and crystallographic data allow us to accomplish this feat. characterizing materials down to the atomic limits. It must Therefore, it is obvious that any curriculum in modern materials must be used with care and attention, in many cases involving materials education must include suitable courses in electron microscopy-TEM- teams of experts from different venues. The fundamentals of spectroscopy. It is also essential that suitable texts be available are, of course, based in physics, so aspiring materials scientists for the preparation of the students and researchers who must exist would be well advised to have prior exposure to, for carry out electron microscopy properly and quantitatively.

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